

**AMENDMENTS TO THE CLAIMS**

This listing of claims will replace all prior versions, and listings, of claims in the application.

**Listing of Claims:**

1. (Currently Amended) A coating composition for production of insulating film, comprising:
  - a) an organic polysiloxane precursor having a weight-average molecular weight ranging from 500 to 30,000, and a molar ratio of hydroxy groups approximately 80% or more of the total condensable functional groups;
  - b) an organic solvent; and
  - c) water.
2. (Original) The coating composition of claim 1, comprising:
  - a) 100 parts by weight of said organic polysiloxane precursor;
  - b) 200 to 2000 parts by weight of said organic solvent; and
  - c) 5 to 60 parts by weight of water.
3. (Cancelled)
4. (Original) The coating composition of claim 1, said organic polysiloxane precursor having a molar ratio of unhydrolyzable functional groups to silicon atoms (functional group/Si) ranging from 0.35 to 0.75.
5. (Original) The coating composition of claim 1, said organic solvent being a non-alcoholic ether based solvent or a non-alcoholic ester based solvent.

6. (Original) The coating composition of claim 1, said organic polysiloxane precursor comprising one or more silane compounds selected from the group consisting of silane compounds represented by Chemical Formulas 1 to 3 below, dimers, or oligomers prepared therefrom as a hydrolyzed and condensed repeating unit:

[Chemical Formula 1]



where

$\text{R}^1$  is hydrogen, an aryl, a vinyl, an allyl, or a linear or branched  $\text{C}_1$  to  $\text{C}_4$  alkyl substituted by fluorine or unsubstituted,

$\text{R}^2$  is a linear or branched  $\text{C}_1$  to  $\text{C}_4$  alkoxy, and

$p$  is an integer of 1 or 2,

[Chemical Formula 2]



where

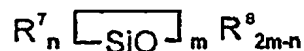
each of  $\text{R}^3$  and  $\text{R}^5$  is independently hydrogen, fluorine, an aryl, a vinyl, an allyl, or a linear or branched  $\text{C}_1$  to  $\text{C}_4$  alkyl substituted by fluorine or unsubstituted,

each of  $\text{R}^4$  and  $\text{R}^6$  is independently a linear or branched  $\text{C}_1$  to  $\text{C}_4$  alkoxy,

$\text{M}$  is a  $\text{C}_1$  to  $\text{C}_6$  alkylene or phenylene, and

each of  $q$  and  $r$  is an integer of 0 to 2, and

[Chemical Formula 3]



where

$R^7$  is hydrogen, fluorine, an aryl, a vinyl, an allyl, or a linear or branched

$C_1$  to  $C_4$  alkyl substituted by fluorine or unsubstituted,

$R^8$  is hydrogen, a hydroxy, or a linear or branched  $C_1$  to  $C_4$  alkoxy or  $-(CH_2)_a-SiR^9R^{10}$   
(where  $a$  is 2 or 3),

$R^9$  is fluorine, an aryl, a vinyl, an allyl, or a linear or branched  $C_1$  to  $C_4$  alkyl substituted  
by fluorine or unsubstituted,

$R^{10}$  is a linear or branched  $C_1$  to  $C_4$  alkoxy; and

each of  $m$  and  $n$  is an integer of 3 to 7.

7. (Original) The coating composition of claim 1, further comprising:

a) a pore generating material.

8. (Original) The coating composition of claim 7, comprising:

a) 5 to 100 parts by weight of said pore generating material for 100 parts by  
weight of said organic polysiloxane precursor.

9. (Original) The coating composition of claim 7, said pore generating material  
being one of materials selected from a group consisting of linear organic molecules, linear  
organic polymers, cross-linked organic molecules, cross-linked organic polymers, hyper-  
branched organic molecules, hyper-branched polymers, dendrimer organic molecules, and

dendrimer organic polymers that are thermally decomposable in the temperature range of 200 to 450 °C.

10. (Original) A preparation method of a low dielectric insulating film comprising the steps of:

a) preparing an organic polysiloxane precursor having a weight-average molecular weight ranging from 500 to 30,000;

b) preparing a coating composition for production of insulating film by mixing i) said organic polysiloxane precursor, ii) an organic solvent, and iii) water;

c) coating said coating composition on a substrate of a semiconductor device; and

d) drying and baking said coating composition to produce insulating film.

11. (Original) The preparation method of claim 10, said organic polysiloxane precursor prepared by mixing:

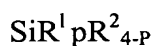
i) one or more silane compounds selected from the group consisting of silane compounds represented by Chemical Formulas 1 to 3 below, dimers, or oligomers prepared therefrom;

ii) an acid catalyst; and

iii) water or a mixture of water and an organic solvent

and hydrolyzing and condensing the same,

Chemical Formula 1



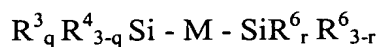
where

$R^1$  is hydrogen, an aryl, a vinyl, an allyl, or a linear or branched  $C_1$  to  $C_4$  alkyl substituted by fluorine or unsubstituted,

$R^2$  is a linear or branched  $C_1$  to  $C_4$  alkoxy, and

p is an integer of 1 or 2,

Chemical Formula 2



where

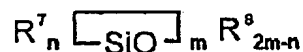
each of  $R^3$  and  $R^5$  is hydrogen, fluorine, an aryl, a vinyl, an allyl, or a linear or branched  $C_1$  to  $C_4$  alkyl substituted by fluorine or unsubstituted,

each of  $R^4$  and  $R^6$  is a linear or branched  $C_1$  to  $C_4$  alkoxy,

M is a  $C_1$  to  $C_6$  alkylene or phenylene, and

each of q and r is an integer of 0 to 2, and

Chemical Formula 3



where

$R^7$  is hydrogen, fluorine, an aryl, a vinyl, an allyl, or a linear or branched  $C_1$  to  $C_4$  alkyl substituted by fluorine or unsubstituted,

$R^8$  is hydrogen, a hydroxy, or a linear or branched  $C_1$  to  $C_4$  alkoxy or  $-(CH_2)_a-SiR^9R^{10}$  (where, a is 2 or 3),

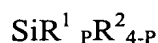
$R^9$  is fluorine, an aryl, a vinyl, an allyl, or a linear or branched  $C_1$  to  $C_4$  alkyl substituted by fluorine or unsubstituted,

$R^{10}$  is a linear or branched  $C_1$  to  $C_4$  alkoxy, and

each of m and n is an integer of 3 to 7.

12. (Original) The preparation method of claim 10, said organic polysiloxane precursor comprising one or more silane compounds selected from the group consisting of silane compounds represented by Chemical Formulas 1 to 3 below, dimers, or oligomers prepared therefrom as hydrolyzed and condensed repeating unit:

Chemical Formula 1



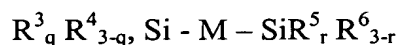
where

$R^1$  is hydrogen, an aryl, a vinyl, an allyl, or a linear or branched  $C_1$  to  $C_4$  alkyl substituted by fluorine or unsubstituted,

$R^2$  is a linear or branched  $C_1$  to  $C_4$  alkoxy, and

p is an integer of 1 or 2,

Chemical Formula 2



where

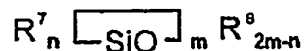
each of  $R^3$  and  $R^5$  is hydrogen, fluorine, an aryl, a vinyl, an allyl, or a linear or branched  $C_1$  to  $C_4$  alkyl substituted by fluorine or unsubstituted,

each of  $R^4$  and  $R^6$  is a linear or branched  $C_1$  to  $C_4$  alkoxy,

M is a C<sub>1</sub> to C<sub>6</sub> alkylene or phenylene, and

each of q and r is an integer of 0 to 2, and

Chemical Formula 3



where

R<sup>7</sup> is hydrogen, fluorine, aryl, a vinyl, an allyl, or a linear or branched C<sub>1</sub> to C<sub>4</sub> alkyl substituted by fluorine or unsubstituted,

R<sup>8</sup> is hydrogen, a hydroxy, or a linear or branched C<sub>1</sub> to C<sub>4</sub> alkoxy or  $-(CH_2)_a-SiR^9R^{10}$  (Where a is 2 or 3),

R<sup>9</sup> is fluorine, an aryl, a vinyl, an allyl, or a linear or branched C<sub>1</sub> to C<sub>4</sub> alkyl substituted by fluorine or unsubstituted,

R<sup>10</sup> is a linear or branched C<sub>1</sub> to C<sub>4</sub> alkoxy, and

each of m and n is an integer of 3 to 7.

13. (Original) The preparation method of claim 10, said composition comprising i) 100 parts by weight of an organic polysiloxane precursor; ii) 200 to 2000 parts by weight of an organic solvent, and iii) 4 to 60 parts by weight of water.

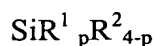
14. (Original) The preparation method of claim 10, said composition further comprising iv) a pore generating material.

15. (Original) The preparation method of claim 14, said composition comprising iv) 5 to 100 parts by weight of said pore generating material for 100 parts by weight of said organic polysiloxane precursor.

16. (Original) The preparation method of claim 14, said pore generating material being one of materials selected from a group consisting of linear organic molecules, linear organic polymers, cross-linked organic molecules, cross-linked organic polymers, hyper-branched organic molecules, hyper-branched polymers, dendrimer organic molecules, and dendrimer organic polymers that are thermally decomposable in the temperature range of 200 to 450°C.

17. (Original) A low dielectric insulating film for a semiconductor device prepared as in claim 10 and comprising one or more silane compounds selected from the group consisting of silane compounds represented by Chemical Formulas 1 to 3 below, dimers, or oligomers prepared therefrom as a hydrolyzed and condensed repeating unit:

Chemical Formula 1



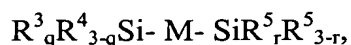
where

$\text{R}^1$  is hydrogen, an aryl, a vinyl, an allyl, or a linear or branched  $\text{C}_1$  to  $\text{C}_4$  alkyl substituted by fluorine or unsubstituted,

$\text{R}^2$  is a linear or branched  $\text{C}_1$  to  $\text{C}_4$  alkoxy and

$p$  is an integer of 1 or 2,

Chemical Formula 2



where

each of  $\text{R}^3$  and  $\text{R}^5$  is hydrogen, fluorine, an aryl, a vinyl, an allyl, or a linear or branched  $\text{C}_1$  to  $\text{C}_4$  alkyl substituted by fluorine or unsubstituted,



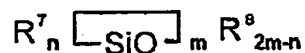
Reply to Office Action dated December 2, 2005

each of  $R^4$  and  $R^6$  is a linear or branched C1 to C4 alkoxy,

M is a C<sub>1</sub> to C<sub>6</sub> alkylene or phenylene, and

each of q and r is an integer of 0 to 2, and

Chemical Formula 3



where

$R^7$  is hydrogen, fluorine, an aryl, a vinyl, an allyl, or a linear or branched C<sub>1</sub> to C<sub>4</sub> alkyl substituted by fluorine or unsubstituted,

$R^8$  is hydrogen, a hydroxy, or a linear or branched C<sub>1</sub> to C<sub>4</sub> alkoxy or

$\text{---}(\text{CH}_2)_a\text{---SiR}^9\text{R}^{10}$  (where a is 2 or 3),

$R^9$  is fluorine, an aryl, a vinyl, an allyl, or a linear or branched C<sub>1</sub> to C<sub>4</sub> alkyl substituted by fluorine or unsubstituted,

$R^{10}$  is a linear or branched C<sup>1</sup> to C<sup>4</sup> alkoxy, and

each of m and n is an integer of 3 to 7.

18. (Original) A semiconductor device comprising the low dielectric insulating film of claim 17.